

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Maher et al.
App. No	: 10/771,283
Filed	: February 2, 2004
For	: HIGH THROUGHPUT METHOD AND SYSTEM FOR SCREENING CANDIDATE COMPOUNDS FOR ACTIVITY AGAINST TARGET ION CHANNELS
Examiner	: S. E. Fernandez
Art Unit	: 1651
Conf No.	: 9653

RESPONSE WITH REQUEST FOR CONTINUED EXAMINATION**Mail Stop AF**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Together with a Request for Continued Examination and in response to the Final Office Action of November 17, 2008 Applicant submits the following: